

*6 Single-wafer: To process wafers one by one

*7 MMT: Stands for "Modified Magnetron Type

Glossary *1 Layer deposition: A process of forming an oxide film, nitride film, other dielectric thin film, or a metal film for electric wiring of semiconductor wafers *2 QTAT: Quick Turn Around Time; To reduce time needed to complete a semiconductor wafer process

*3 I P-CVD: Low Pressure Chemical Vapor Deposition

*4 Batch: To process multiple wafers in groups

*5 ALD: Atomic Layer Deposition